

Application No. 10/576,486  
Paper Dated: January 8, 2009  
In Reply to USPTO Correspondence of October 8, 2008  
Attorney Docket No. 0388-061179

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/576,486 Confirmation No. : 6114  
Applicant : Chie Ishikawa et al.  
Filed : December 21, 2006  
Title : SURFACE DEFECT INSPECTING METHOD AND DEVICE  
Group Art Unit : 2877  
Examiner : Iyabo S. Alli  
Customer No. : 28289

Mail Stop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Sir:

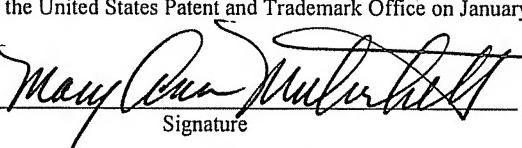
In response to the Office Action dated October 8, 2008, Applicants submit the following amendments and remarks.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.

I hereby certify that this correspondence is being electronically submitted to the United States Patent and Trademark Office on January 8, 2009.

01/08/2009  
Date

  
Signature

Mary Ann Mulvihill

Typed Name of Person Signing Certificate